FEB 27 2006 W

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ipplication of Docket No: Q79569

Yoshihiko UCHIDA, et al.

Appln. No.: 10/765,220

Group Art Unit: 2818

Confirmation No.: 7643

Examiner: Andy Huynh

Filed: January 28, 2004

For: ORGANIC SEMICONDUCTOR ELEMENT HAVING HIGH INSULATION

STRENGTH AND FABRICATION METHOD THEREOF

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of two (2) months, extending the time for responding to the Office Action of September 27, 2005 to February 27, 2006.

A check for the statutory fee of \$450.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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Date: February 27, 2006